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H.C. Jr  
K. Song  
10/24/02

## PROTEST UNDER 37 CFR 1.291(a)

The cited prior art is relevant to application (Continuation In Part for co-pending  
09/210,086 09/210,428 09/210,485) claims 11,12,13 and 46.

Applicant: Symyx Technologies, Inc

Date filed: Dec. 11, 1998

Title: SENSOR ARRAY-BASED SYSTEM AND METHOD FOR RAPID  
MATERIALS CHARACTERIZATION

As noted in Lai et.al. as well as Denlinger et.al calorimeters are described that use  
membranes made by etching windows in Si to make thermally isolated structures (claim  
13) for sample measurements (heat capacity and specific heat) relating to claims 11 and  
12. In addition in Denlinger et.al. the described calorimeters are made "...on 2in. wafers  
and are able to fit nine on a wafer." ( pg. 947 col 2 lines 1-2) Which relates to claim 46.



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Enclosed

1. 2 copies of protest under 37 CFR 1.291(a)
2. 2 copies articles relating to protest
3. 2 copies Information Disclosure Form PTO/SB/08B
4. Self addressed postcard (please affix office stamp)

Please forward to examiner for consideration and service of copies to attorneys

Protest of Continuation In Part of co-pending applications:

09/210,086 09/210,428 09/210,485

Applicant: Symyx Technologies Inc.

Date filed: Dec 11, 1998

Title: SENSOR ARRAY-BASED SYSTEM AND METHOD FOR RAPID  
MATERIALS CHARACTERIZATION

First Inventor: Mansky, Paul

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